INSTRUCTIONS:

- 1. Read the Access to Intellectual Property & Non-Disclosure Agreement.
- 2. Fill in required fields (name, city, and signatory and witness information). Print all information legibly.
- 3. Sign the agreement. Original ("wet") signatures or secure electronic are required.
- 4. Email signed form to Sarah Neville (<u>Sarah.Neville@cmc.ca</u>). Note: A high resolution photograph of the signed agreement is acceptable.

2020 ACTIVE SILICON PHOTONICS FABRICATION COURSE (ON-LINE) ACCESS TO INTELLECTUAL PROPERTY & NON-DISCLOSURE AGREEMENT

I		of the City/Town of
(Course Parti	cipant Full Name, Print)	
		acknowledge and agree that:
	(City/Town, Print)	
through CANADIAN MIC MICROSYSTEMS (herein electronic content or and/ intellectual property and co including Confidential Informathas permission to share	CROELECTRONICS CORPO called "CMC") I may have for fabricated multi-project infidential and proprietary info- ation of CMC, Confidential Info	wafer chips containing non-public rmation ("Confidential Information"), formation of third parties which CMC and Confidential Information of other
undertake that I will not at this ordered so to do by law or co	s time or any future time disclo ourt process. If I am required to provide CMC with prompt write	onfidential Information, I declare and ose any Confidential Information unless to disclose Confidential Information by tten notice to enable CMC to seek a
I further declare and undertake	e:	
(a) not to record the course, a	ınd	
(b) not to take screenshots of	course material, and	
Information obtained throwwould be stored (including	ugh my association with CMC	and electronic copies of Confidential from any and all systems where they as or backup storage devices) upon the my association with CMC.
Course Participant:		
Signature:		
Name:		
Title:		
Institution / Company Name:		
Address:		
Date:		